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Docket No.: M4065.0466/P466

(PATENT)

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Neal Rueger

Application No.: 09/938,644

**Art Unit: 1765** 

Filed: August 27, 2001

Examiner: T. Mackey

For: METHOD AND APPARATUS FOR

MICROMACHINING USING A MAGNETIC

FIELD AND PLASMA ETCHING

#### **AMENDMENT**

MS Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action dated April 15, 2004, please amend the above-identified U.S. patent application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 12 of this paper.

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